

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Confirmation No.: 8995  
Makiko KITAZOE et al. Group Art Unit: 1715  
Application No.: 10/593,444 Examiner: Joseph Albert MILLER, Jr.  
Filed: February 5, 2007 Attorney Docket No.: 029567-00011  
For: UNIT-LAYER POST-PROCESSING CATALYST CHEMICAL-VAPOR-  
DEPOSITION APPARATUS AND ITS FILM FORMING METHOD

**RESPONSE WITH FILING OF A REQUEST FOR  
CONTINUED EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114**

**Mail Stop RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 24, 2011

Sir:

This paper is submitted in reply to the outstanding Office Action dated August 24, 2010. The period for response is extended three months, from November 24, 2010, to February 24, 2011, with payment of the appropriate fees. Prior to continued examination of the above-identified application, please consider the amendments and remarks set forth on the following pages:

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 7.